Integrated Electrothermal Modeling of RF MEMS Switches for Improved Power Handling Capability

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RF MEMS switches have been presented by several researchers for use in transmit/receive switch circuits, tunable filters, and beam steering of antenna arrays [1], [2]. The benefits of RF MEMS switches are their low on-impedance, high off-impedance, highly linear behavior, and, in many cases, nearly zero power consumption [3]. Drawbacks of RF MEMS switches include slow switching, high actuation voltage, high packaging cost, and low power handling capability [3]. Of these challenges, there appears to be substantial room to improve power handling without sacrificing device performance. Hence, this paper focuses on developing models predicting the power handling capability of a switch and corroborating these models with experiments. In particular, our model incorporates a new finite element-boundary integral method to solve for the electromagnetic fields.

Fig. 1 shows an explanatory drawing of a sample RF MEMS shunt switch. The switch consists of a beam placed between the ground lines of a CPW waveguide. Electrostatic force pulls the beam down into contact with the signal line, where metal-to-metal contact with the dimple shorts the waveguide. When the beam is down, current flows across the contact and through the beam, causing them to heat up. For high power, this joule heating causes melting or welding of the contact, leading to failure. To accurately predict the power handling capability of a switch, we have developed a linked electrothermal switch model. This model predicts the current density using electromagnetic modeling, which is then used as a heat source in the thermal model, temperature giving a temperature prediction. Finally, a nanoscale model of the contact point predicts the temperature at the contact, which is the highest temperature in the switch.

Figure 1: Sample RF MEMS switch

Multi-Physics Modeling

The first step is simulation of the current density. We used a new formulation developed to simulate MEMS switches. This formulation simultaneously models a finite element domain and a detached boundary element domain in three dimensions [4]. This allows easy modeling of the substrate and the MEMS beam. The substrate is modeled using well-established finite element modeling, while the MEMS beam is modeled using boundary elements, allowing deformation of the beam without requiring continuous remeshing of the problem. Moreover, the required unknown—current density—is solved for directly in the boundary element domain. The model also includes the effect of the electrical contact resistance at the contact point. In this way, the current density throughout the switch and the contact is calculated with sufficient accuracy to predict local conductor losses.

The conductor losses are then used as a heat generation source in the thermal model. Thermal effects are simulated using a two-dimensional finite element method which assumes constant temperature through the thickness of the beam. The model also includes the effect of thermal contact resistance at the contact point, restricting heat flow across the contact. In addition, because electrical resistivity of the metal is a strong function of temperature, the model iterates to find a convergent temperature solution. Convergence to within 1% on the Kelvin scale is normally achieved after two or three iterations.

When current flows through an electric contact, the maximum temperature in the device typically occurs at the individual contact asperities [5]. This asperity temperature is called the contact supertemperature, and it is a function of the temperature in the micromachined beam, which is calculated using the electromagnetic and thermal models described above. Using a nanoscale model of the microscopic contact asperities, the supertemperature is calculated, which represents the highest temperature in the switch and the point of initial switch failure. For example, contacts made of gold have been experimentally shown to soften and plastically deform at temperatures as low as 100°C [6]. Hence, failure is likely if the linked electro-thermal model, which includes the nanoscale supertemperature model, predicts a gold asperity temperature higher than this limit.

Sample Results and Experimental Validation

Fig. 2 shows a contour plot of the asperity supertemperature in a switch similar to the one shown in Fig. 1. The results show that super-temperature rises rapidly with both signal power and contact resistance. For contact resistance as low as 0.5 Ω , only about 200 mW of carried power will cause contact softening for this case.

In order to validate the model predictions, RF MEMS devices are now being fabricated with integrated temperature sensors to allow measurement of the beam temperature. The model will then be used to design switches for improved power handling performance.

Figure 2: Contour plot of asperity supertemperature

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